	Application No.	Applicant(s)	<u>.                                    </u>
Notice of Allowability	10/693,912	ISHII ET AL.	
	Examiner	Art Unit	
	Shih-Chao Chen	2821	•
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED i or other appropriate comm IGHTS. This application is	n this application. If not included unication will be mailed in due cours	se. THIS
1. $\boxtimes$ This communication is responsive to <u>the amendment filed</u>	on Oct. 12, 2005.		
2. The allowed claim(s) is/are <u>3-33</u> .			
<ol> <li>Acknowledgment is made of a claim for foreign priority under a)</li></ol>	e been received. e been received in Application	on No	rom the
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		e a reply complying with the require	ments
4. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give			CE OF
<ol> <li>CORRECTED DRAWINGS (as "replacement sheets") must</li> <li>(a) ☐ including changes required by the Notice of Draftspers</li> <li>1) ☐ hereto or 2) ☐ to Paper No./Mail Date</li> <li>(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date</li> </ol>	son's Patent Drawing Revie		
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t			() of
6. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT			the
		<del>-</del>	
Attachment(s)		•	
1. Notice of References Cited (PTO-892)		formal Patent Application (PTO-152	2)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	Paper No.	ummary (PTO-413), /Mail Date	
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date		Amendment/Comment	
<ol> <li>Examiner's Comment Regarding Requirement for Deposit of Biological Material</li> </ol>		Statement of Reasons for Allowand	ce
•	9. 🗌 Other		
		Shih Thau CL— Shih Chao Chan Dahard Evardoned	

U.S. Patent and Trademark Office PTOL-37 (Rev. 7-05) Application/Control Number: 10/693,912

Art Unit: 2821

## **DETAILED ACTION**

## **Drawings**

1. The drawings were received on Oct. 12, 2005. These drawings are accepted by the Examiner.

## Allowable Subject Matter

- 2. Claims 3-33 are allowed (Claims 1-2 are canceled by Applicant).
- 3. The following is an examiner's statement of reasons for allowance:

The primary reason for the allowance of claims 3-8, 10-12 and 20-25 is the inclusion of the limitation of the slots formed on one side of the radiating waveguide are disposed such that they gradually deviate from the center axis in the longitudinal direction of the radiating waveguide. It is this limitation found in each of the claims, as it is claimed in the combination, that has not been found, taught or suggested by the prior art of record which makes these claims allowable over the prior art.

The primary reason for the allowance of claims 9,13-19 and 26-33 is the inclusion of the limitation of a coupling window having a variable width is disposed at the power-feeding portions for feeding power from the power-feeding waveguide to the radiating waveguide. It is this limitation found in each of the claims, as it is claimed in the combination, that has not been found, taught or suggested by the prior art of record which makes these claims allowable over the prior art.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably Application/Control Number: 10/693,912

Statement of Reasons for Allowance."

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Correspondence

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Shih-Chao Chen whose telephone number is (571) 272-

accompany the issue fee. Such submissions should be clearly labeled "Comments on

1819. The examiner can normally be reached on Monday-Friday from 7 AM to 4:30

PM, First Fri. off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Don Wong can be reached on (571) 272-1834. The fax phone number for

the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the

Patent Application Information Retrieval (PAIR) system. Status information for

published applications may be obtained from either Private PAIR or Public PAIR.

Status information for unpublished applications is available through Private PAIR only.

For more information about the PAIR system, see http://pair-direct.uspto.gov. Should

you have questions on access to the Private PAIR system, contact the Electronic

Business Center (EBC) at 866-217-9197 (toll-free).

Shih-Chao Chen Primary Examiner

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SHIH-CHAO CHEN RIMARY EXAMMER

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SXC October 24, 2005